



Appl. No. 10/607,869

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. .... 10/607,869  
Filing Date ..... June 27, 2003  
Inventor ..... Zhongze Wang  
Assignee ..... Micron Technology, Inc.  
Group Art Unit ..... 2812  
Examiner ..... Jennifer M. Kennedy  
Attorney's Docket No. .... MI22-2343  
Customer No. .... 021567  
Title: Method of Forming Silicon-on-Insulator Comprising Integrated Circuitry

**RESPONSE TO MARCH 10, 2005 OFFICE ACTION**

To: Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

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**AMENDMENTS**

**Introductory Comments**

In reply to the Office Action of March 10, 2005, applicant amends and remarks as follows.